

The transistor, the inverter, and other gates

Luca Pezzarossa and Martin Schoeberl

Agenda

1. The need for a controlled switch
2. A brief history of the transistor
3. The MOSFET transistor
4. The inverter ('NOT' gate)
5. Other gates

The need for a controlled switch

Information representation

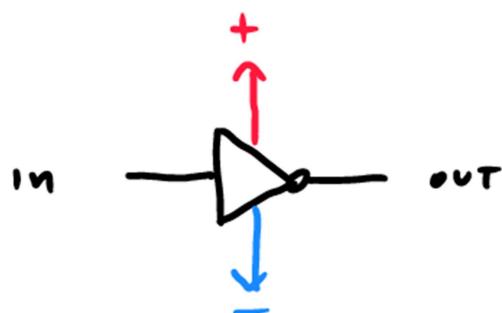
- **Binary number representation**
 - Foundation of digital computing
 - Foundation of digital electronics
- **Physical levels**
 - Logic 1: High voltage (5V, 3.3V, 1.8V, or others)
 - Logic 0: Low voltage (e.g., 0V)
- **A sort of 'controlled switch' is needed to perform computations**

Controlled switch in a circuit

NOT GATE



|||

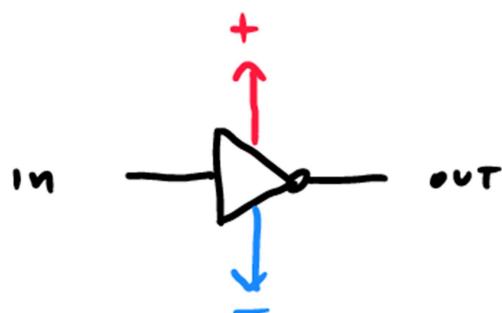


Controlled switch in a circuit

NOT GATE



|||

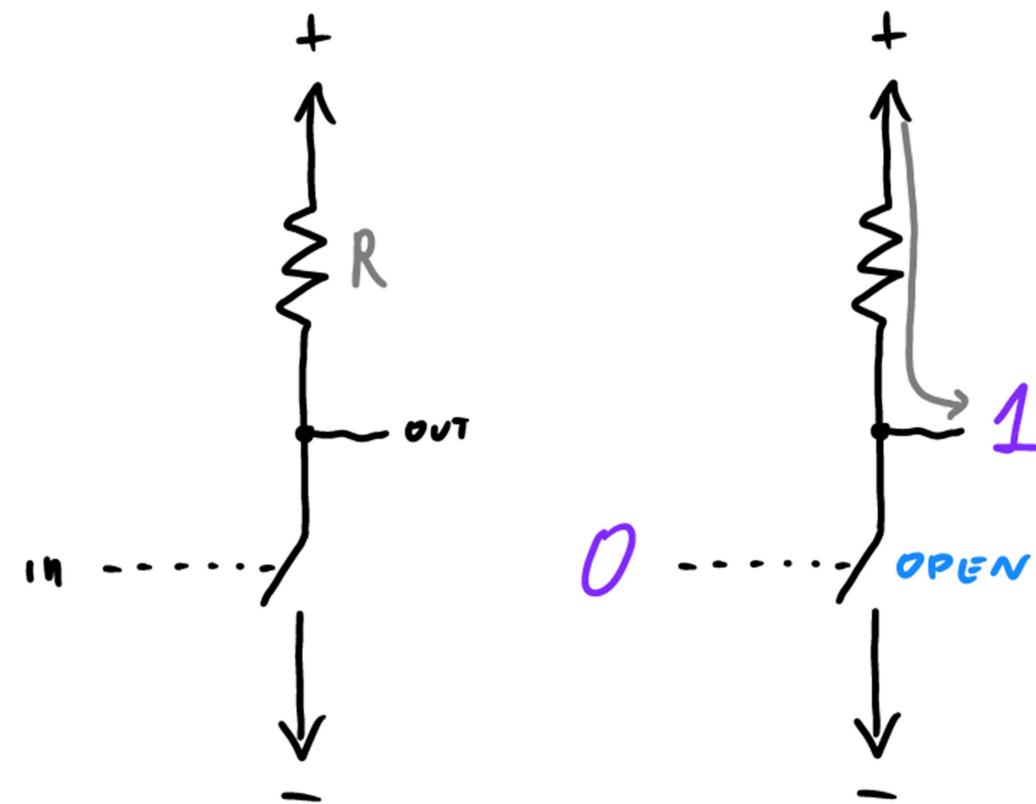
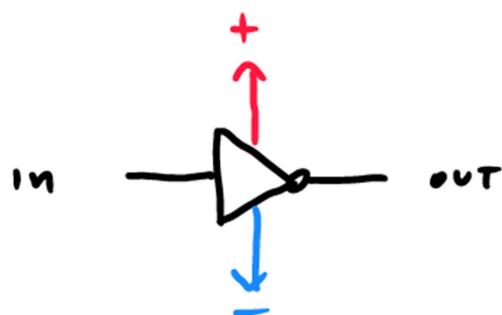


Controlled switch in a circuit

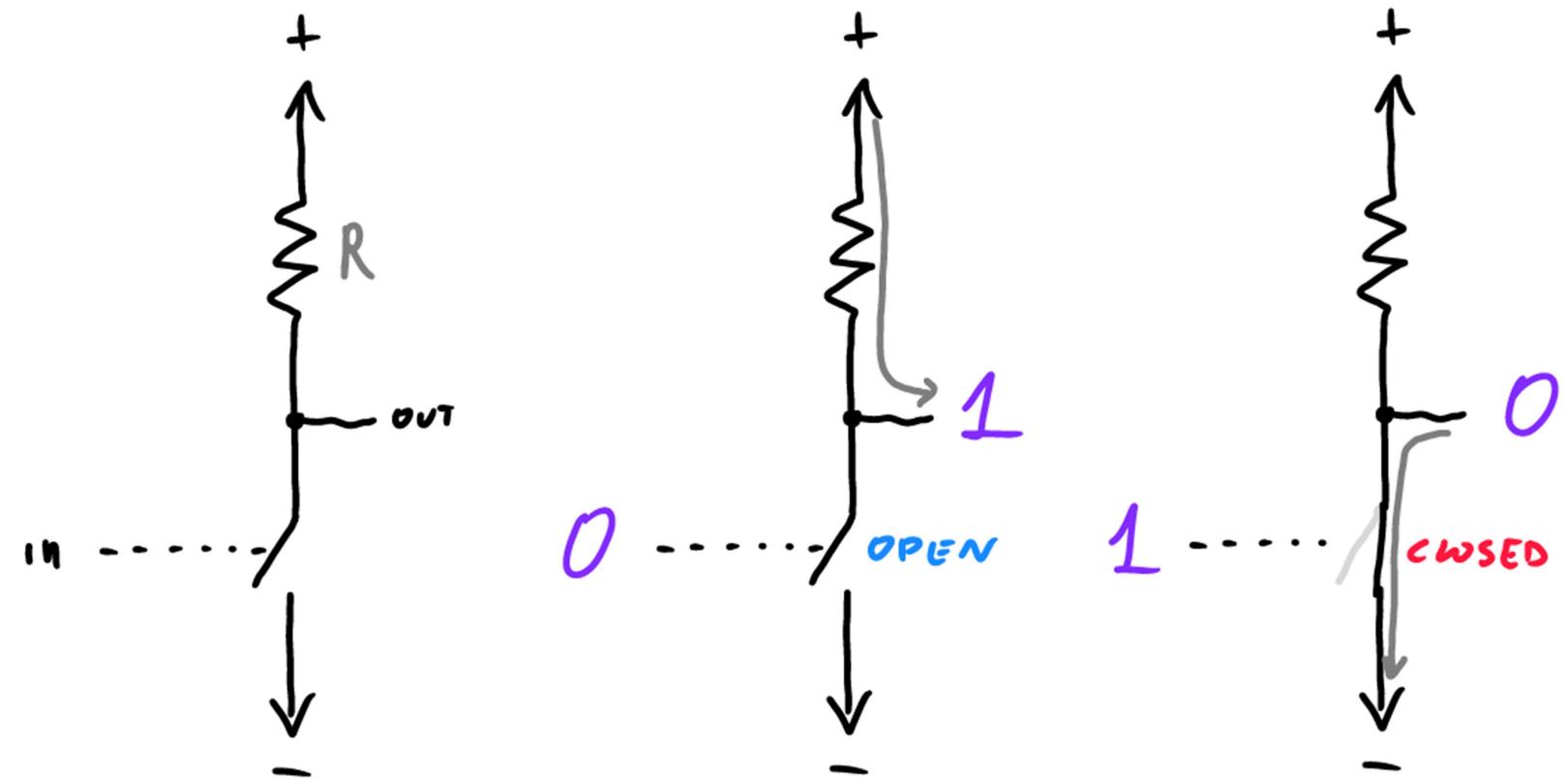
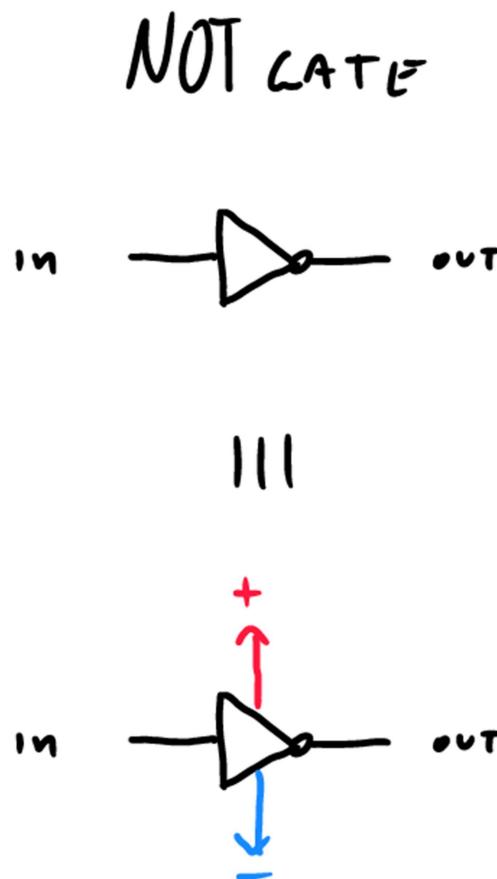
NOT GATE



III



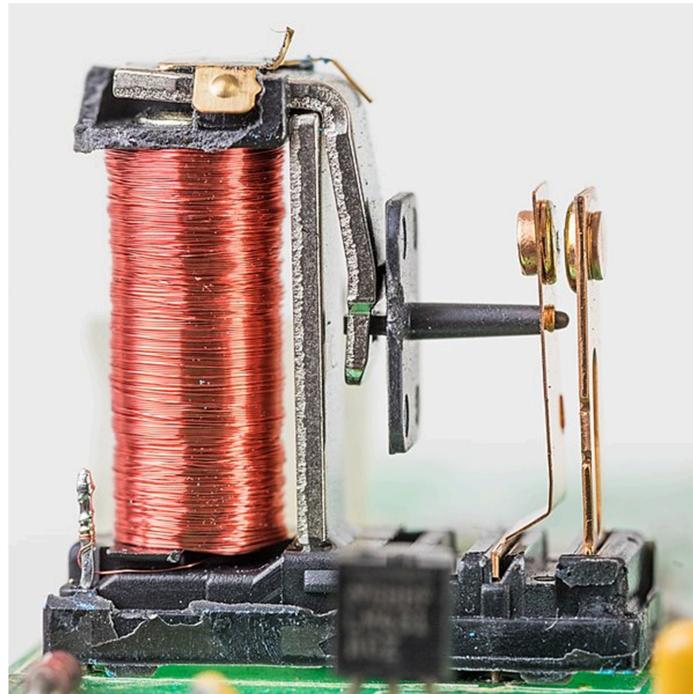
Controlled switch in a circuit



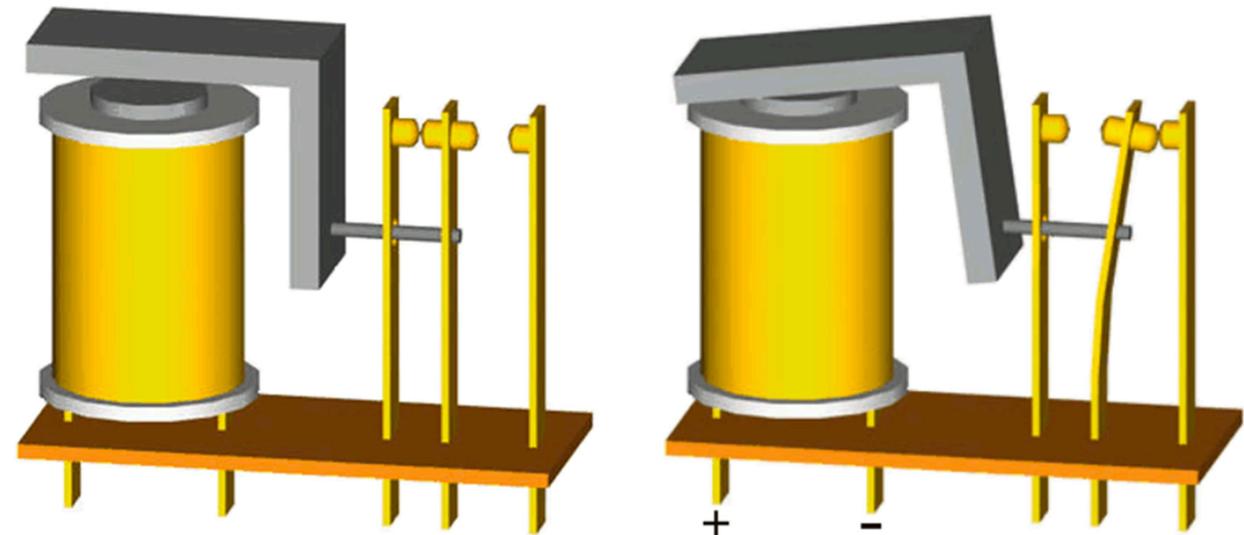
Early technologies: Relays

- **Mechanical relays**
 - Controlled by electromagnets
 - Early computers used relays for logic operations

Early technologies: Relays



© Raimond Spekking / CC BY-SA 4.0 (via Wikimedia Commons)
(https://commons.wikimedia.org/wiki/File:Delta_Electronics_DPS-350FB_A_-_board_1_-_OEG_SDT-SS-112M_-_case_removed-3045.jpg), <https://creativecommons.org/licenses/by-sa/4.0/legalcode>



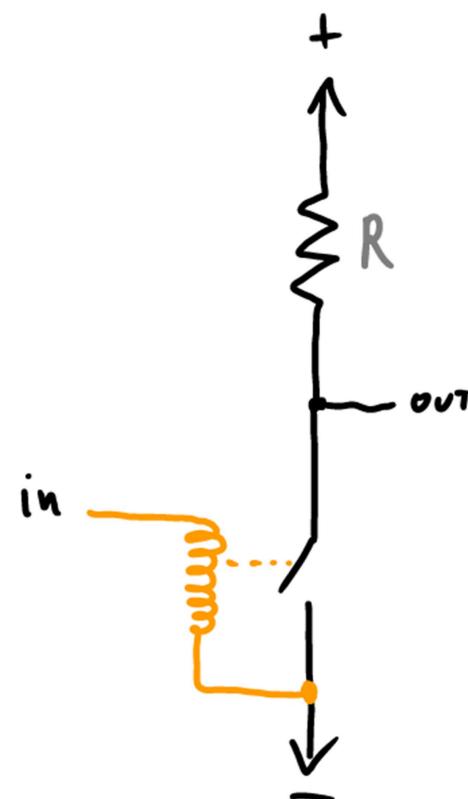
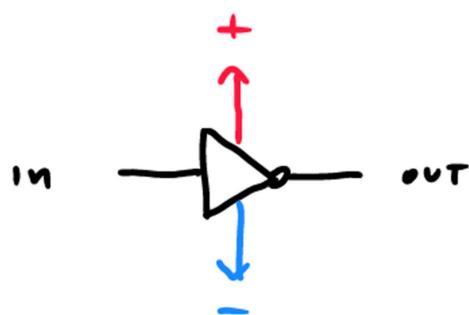
Relay_principle_horizontal.jpg: Digitalos derivative work: Digitalos (talk)
(https://commons.wikimedia.org/wiki/File:Relay_principle_horizontal_new.gif), „Relay principle horizontal new“, Split GIF frames. by L.P., <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Early technologies: Relays

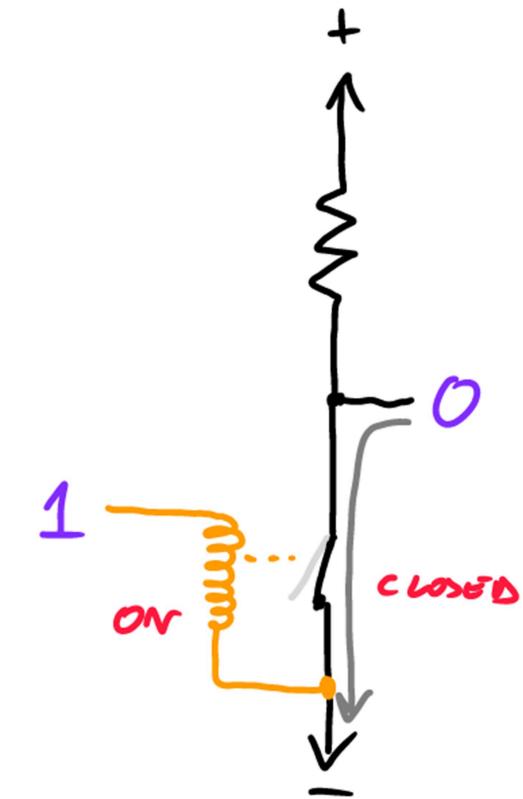
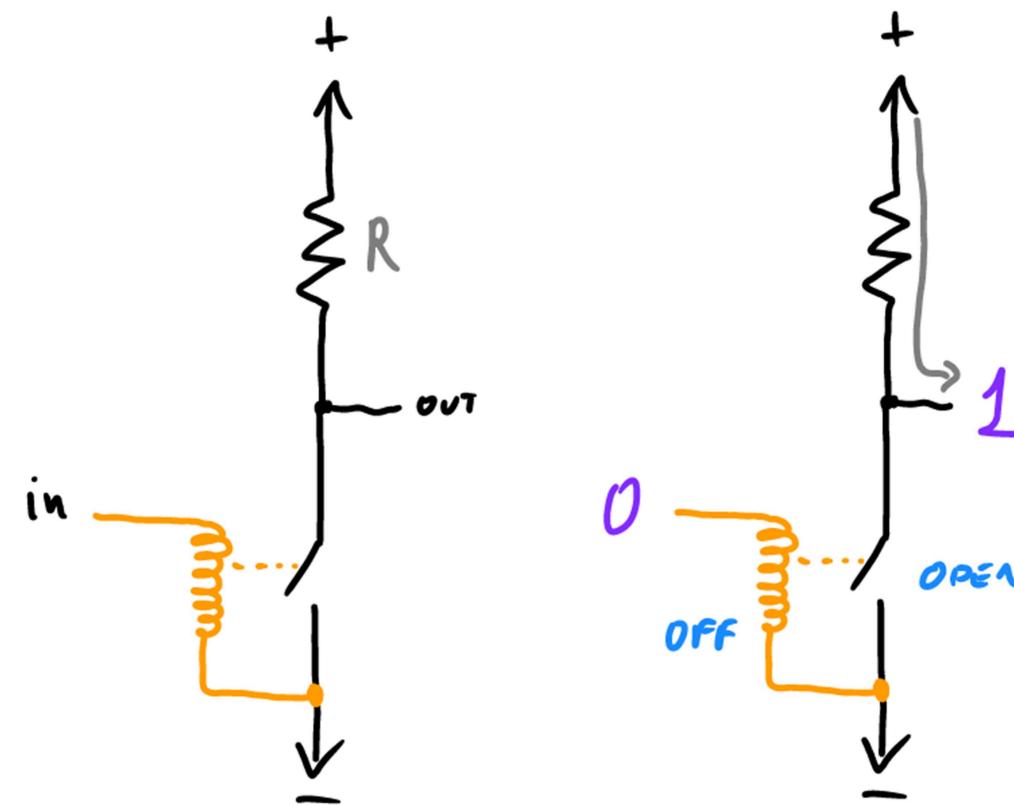
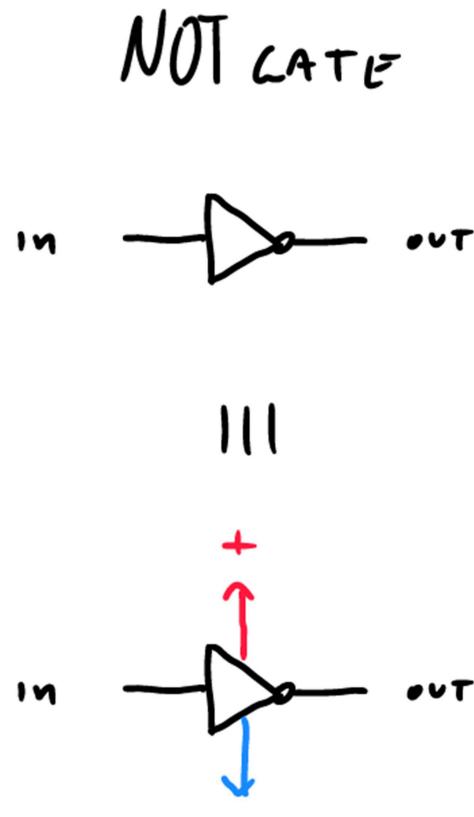
NOT GATE



III



Early technologies: Relays



Early technologies: Relays

- **Advantages**
 - Easy to build
 - Support high loads
- **Disadvantages**
 - Slow switching speed
 - Prone to mechanical wear
 - Loud

Early technologies: Vacuum tubes

- **Vacuum tubes**
 - Used thermionic emission to control current flow
- **Acts as a controlled switch**

Early technologies: Vacuum tubes

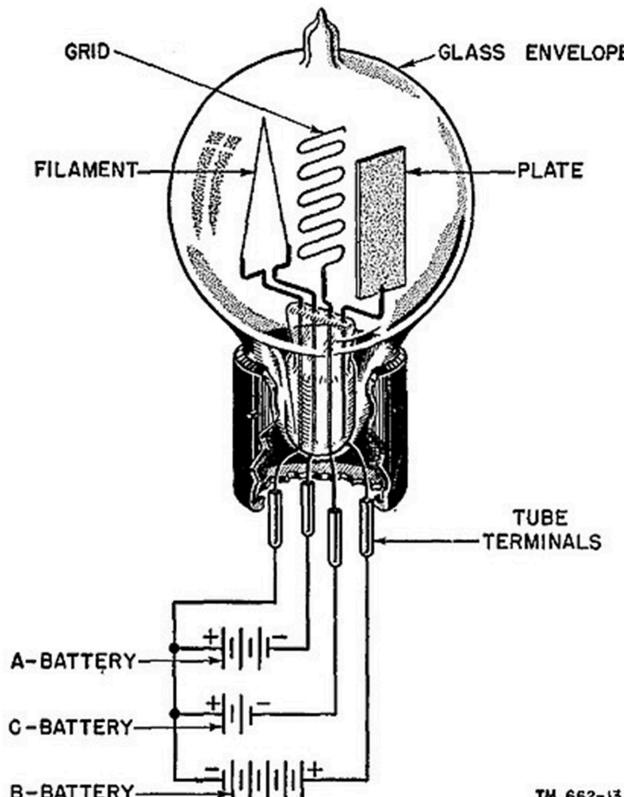


Figure 4. Construction of DeForest's three-element tube, or triode.



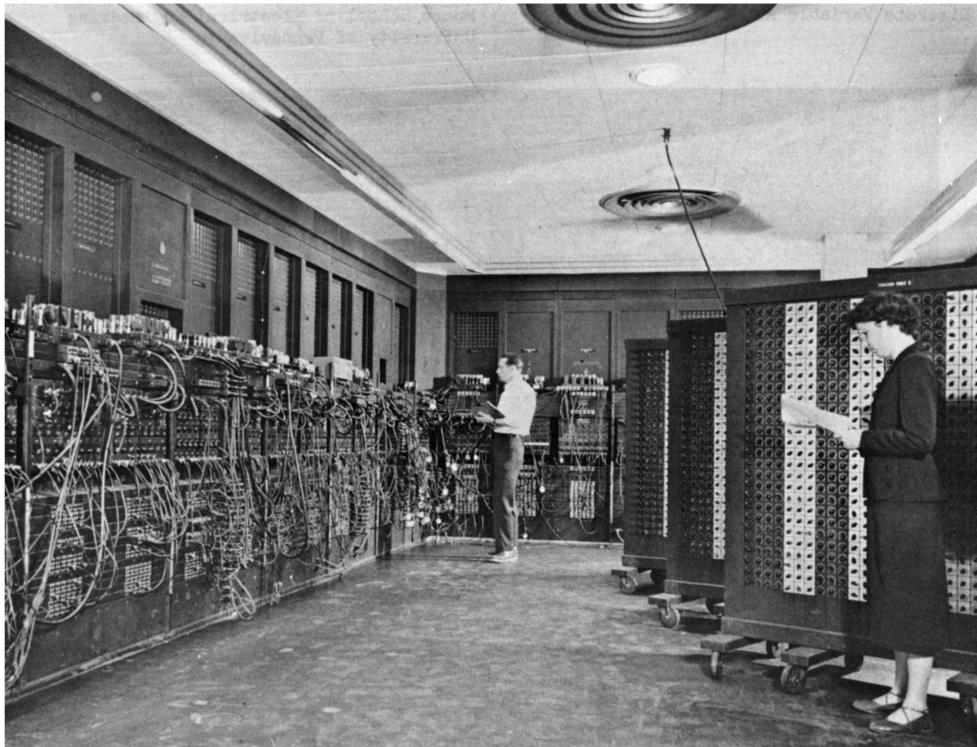
Stefan Riepl (Quark48) (<https://commons.wikimedia.org/wiki/File:Elektronenroehren-auswahl.jpg>), „Elektronenroehren-auswahl“, <https://creativecommons.org/licenses/by-sa/2.0/de/legalcode>

Departments of the Army and the Air Force
(https://commons.wikimedia.org/wiki/File:TRIODE_TM11_662 FIG_4.jpg), „TRIODE TM11 662 FIG 4“, marked as public domain, more details on Wikimedia Commons: <https://commons.wikimedia.org/wiki/Template:PD-US>

Early technologies: Vacuum tubes

- **Advantages**
 - No moving parts
 - Faster than relays
- **Disadvantages**
 - Bulky and fragile
 - High power consumption
 - Excessive heat generation

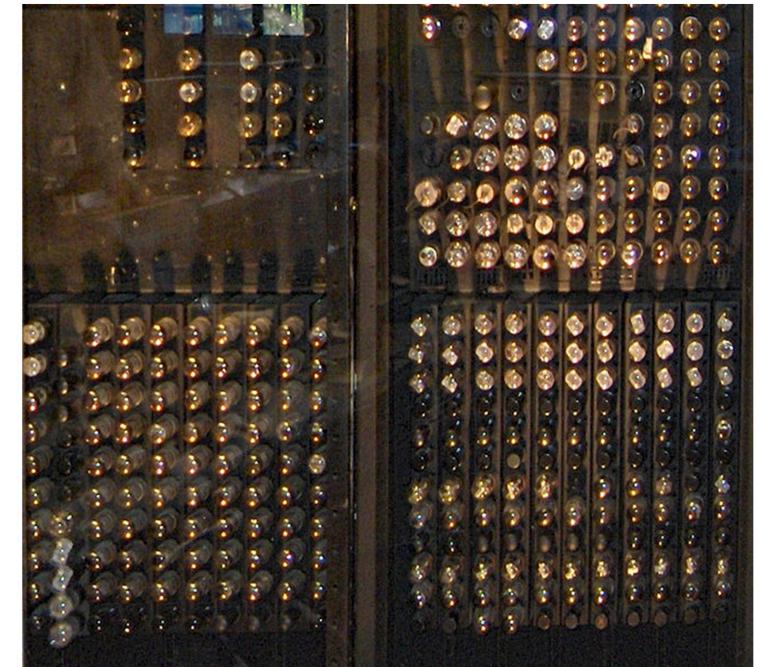
EINAC (1946)



Unknown author

(https://commons.wikimedia.org/wiki/File:Glen_Beck_and_Betty_Snyder_program_the_ENIAC_in_building_328_at_the_Ballistic_Research_Laboratory.jpg), „Glen Beck and Betty Snyder program the ENIAC in building 328 at the Ballistic Research Laboratory“, marked as public domain, more details on Wikimedia Commons: <https://commons.wikimedia.org/wiki/Template:PD-US>

The original uploader was TexasDex at English Wikipedia.
(https://commons.wikimedia.org/wiki/File:ENIAC_Penn2.jpg), „ENIAC Penn2“,
<https://creativecommons.org/licenses/by-sa/3.0/legalcode>



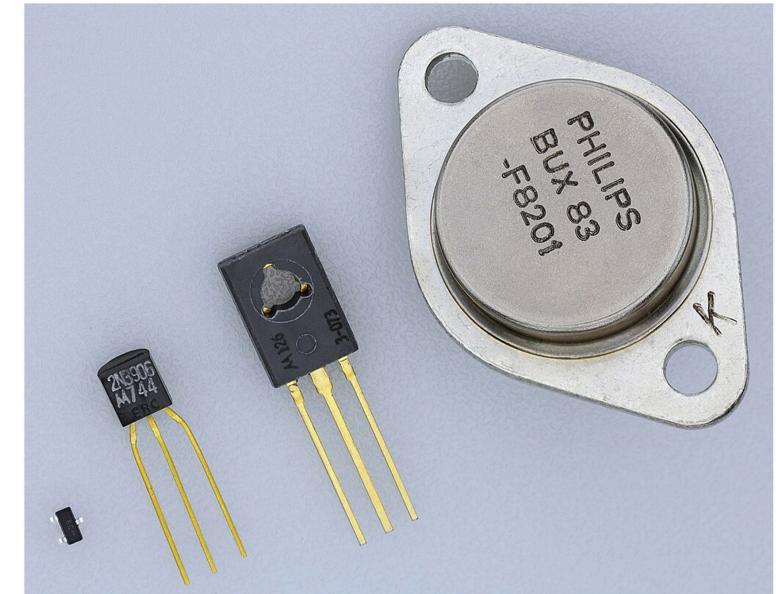
Transition to solid-state devices

- **The need for improvement**
 - Relays and vacuum tubes were not scalable
 - High power and size limitations
- **Solution**
 - Solid-state devices transistors
 - Smaller, faster, cheaper, and more reliable

Transition to solid-state devices



Stefan Riepl (Quark48) (<https://commons.wikimedia.org/wiki/File:Elektronenroehren-auswahl.jpg>), „Elektronenroehren-auswahl“, <https://creativecommons.org/licenses/by-sa/2.0/de/legalcode>



Mister rf at English Wikipedia ([https://commons.wikimedia.org/wiki/File:Transistorer_\(cropped\).jpg](https://commons.wikimedia.org/wiki/File:Transistorer_(cropped).jpg)), „Transistorer (cropped)“, <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

A brief history of the transistor

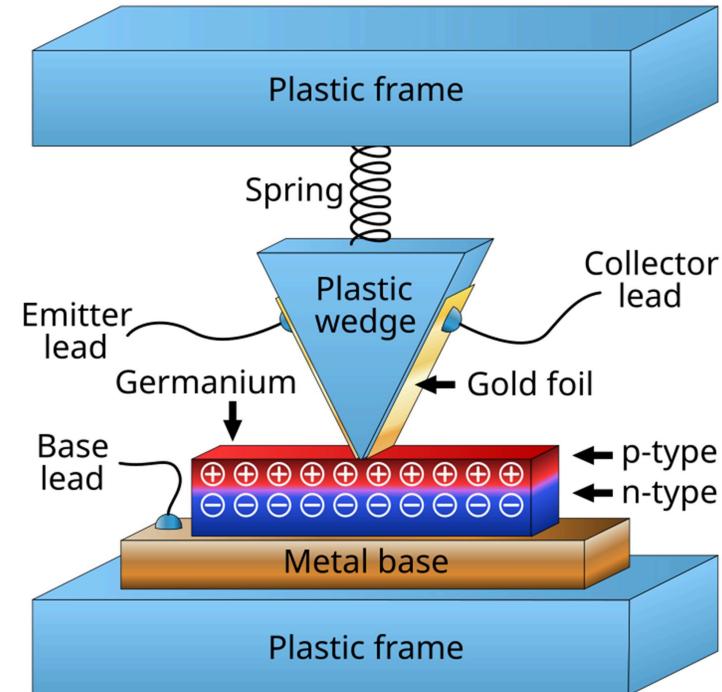
The point-contact transistor

- **The first transistor**
- **Bell Labs (1947)**
 - by John Bardeen, Walter Brattain, and William Shockley
- **Goal**
 - Replace vacuum tubes with a solid-state solution

The point-contact transistor



Federal employee (<https://commons.wikimedia.org/wiki/File:Replica-of-first-transistor.jpg>), „Replica-of-first-transistor“, marked as public domain, more details on Wikimedia Commons: <https://commons.wikimedia.org/wiki/Template:PD-US>



忍者猫 (https://commons.wikimedia.org/wiki/File:Point-contact_transistor.svg), „Point-contact transistor“, <https://creativecommons.org/publicdomain/zero/1.0/legalcode>

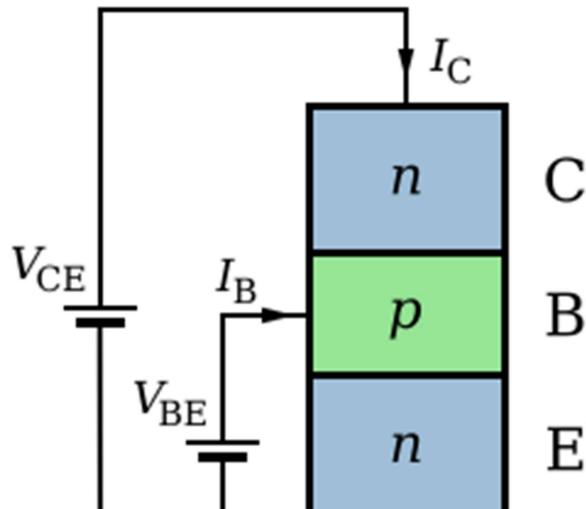
The point-contact transistor

- **Structure:** Germanium crystal with two gold contacts
- **Functionality:** Amplified electrical signals
- **Limitations:** Fragile and difficult to manufacture
- **The science behind it was now demonstrated!**

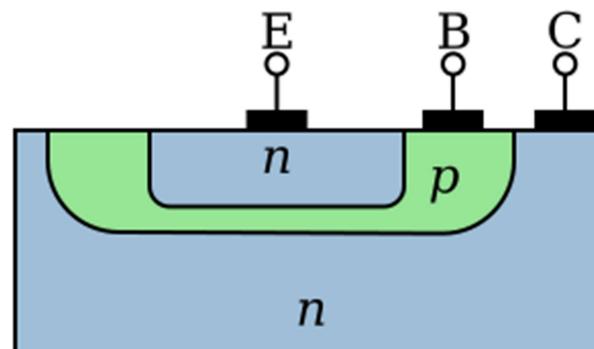
The Bipolar Junction Transistor (BJT)

- **Bell Labs (1948)**
 - by William Shockley
- **Structure:** Three semiconductor layers
- **Amplifies a current**
- **Two types:** (NPN or PNP)
- **Advantages:** More robust and manufacturable than point-contact transistors
- **Applications:** Radios, early computers, and amplifiers

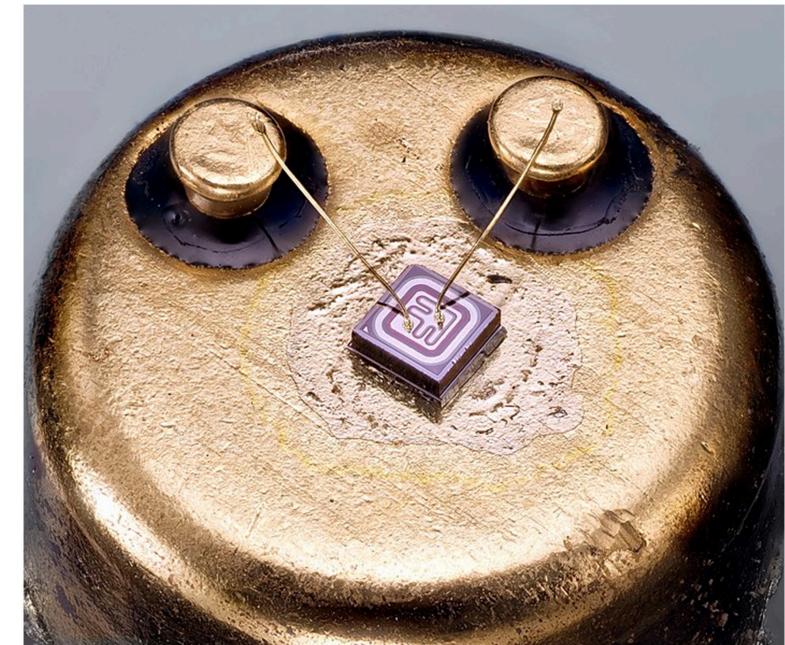
The Bipolar Junction Transistor (BJT)



Inductiveload
(https://commons.wikimedia.org/wiki/File:NPN_BJT_-_Structure_&_circuit.svg), „NPN BJT - Structure & circuit“, <https://creativecommons.org/licenses/by-sa/3.0/legalcode>



Inductiveload
([https://commons.wikimedia.org/wiki/File:NPN_BJT_\(Planar\)_Cross-section.svg](https://commons.wikimedia.org/wiki/File:NPN_BJT_(Planar)_Cross-section.svg)), „NPN BJT (Planar) Cross-section“, marked as public domain, more details on Wikimedia Commons:
<https://commons.wikimedia.org/wiki/Templat e:PD-self>



Mister rf
(https://commons.wikimedia.org/wiki/File:IPRS_BANEASA_2N2222.jpg), <https://creativecommons.org/licenses/by-sa/4.0/legalcode>

Transition from Germanium to Silicon

- **Germanium was initially used but had limitations**
 - Unstable at high temperatures
 - Stability means maintain its properties and performance at different temperatures
- **Silicon emerged as the better material**
 - Abundant and thermally stable
- **First silicon transistor**
 - 1954 by Texas Instruments

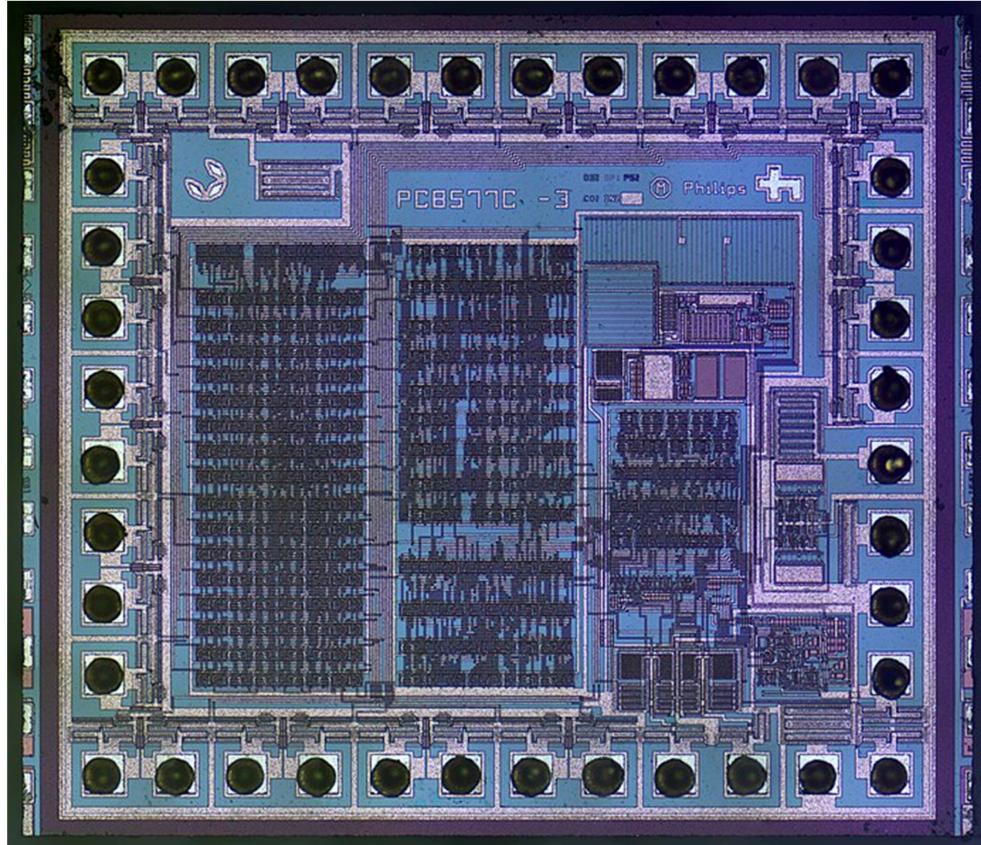
The Metal-Oxide-Semiconductor Field-Effect Transistor (MOSFET)

- **Bell Labs (1959)**
 - by Mohamed Atalla and Dawon Kahng
- **Structure:** More later...
- **Advantages**
 - Scalable for miniaturization
 - Low power consumption

The Impact of the MOSFET

- **Enabled the development of integrated circuits (ICs)**
- **MOSFETs are the foundation of:**
 - Microprocessors
 - Memory chips
 - Digital logic circuits
 - ...

The impact of the MOSFET

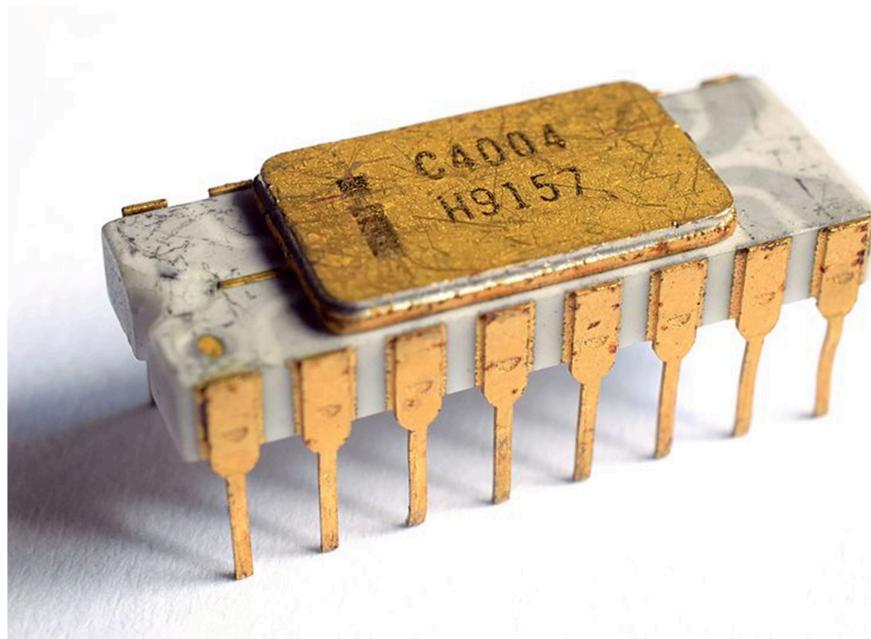


cole8888, <https://flickr.com/photos/187597251@N05/> (aka Cole L)
([https://commons.wikimedia.org/wiki/File:NXP_PCF8577C_LCD_driver_with_I^E2C_\(Colour_Corrected\).jpg](https://commons.wikimedia.org/wiki/File:NXP_PCF8577C_LCD_driver_with_I%5E2C_(Colour_Corrected).jpg)), „NXP PCF8577C LCD driver with I^EC (Colour Corrected)“, <https://creativecommons.org/licenses/by-sa/2.0/legalcode>

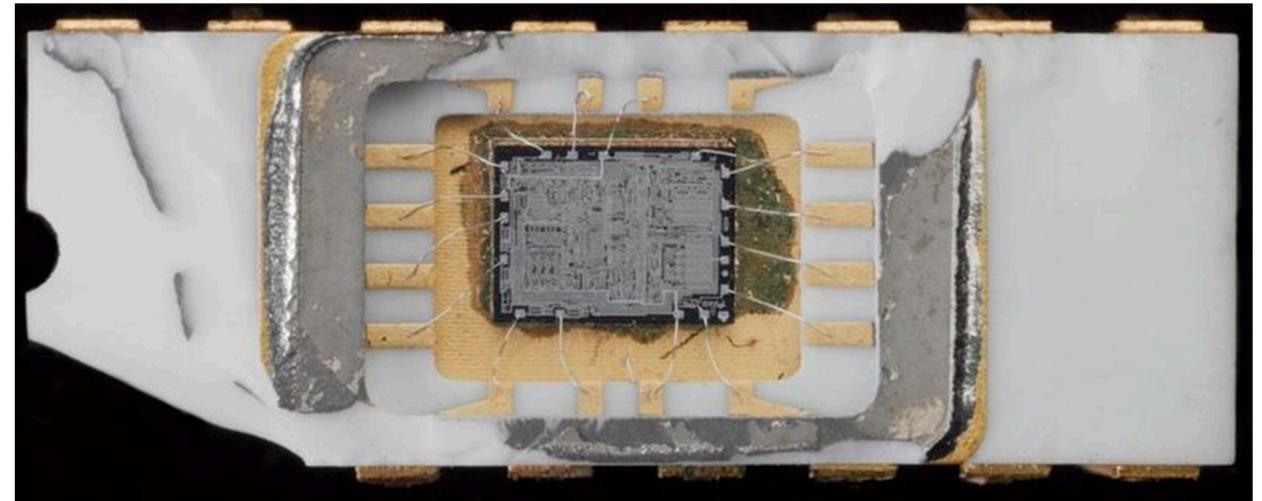
The Integrated circuit revolution

- **First ICs contained only a few transistors**
- **Moore's Law (1965)**
 - Predicted the doubling of transistors on a chip every two years
- **1971:** Intel 4004 (First microprocessor)
 - 2,300 transistors
- **2020s:** Modern processors
 - Billions of transistors

The Integrated circuit revolution

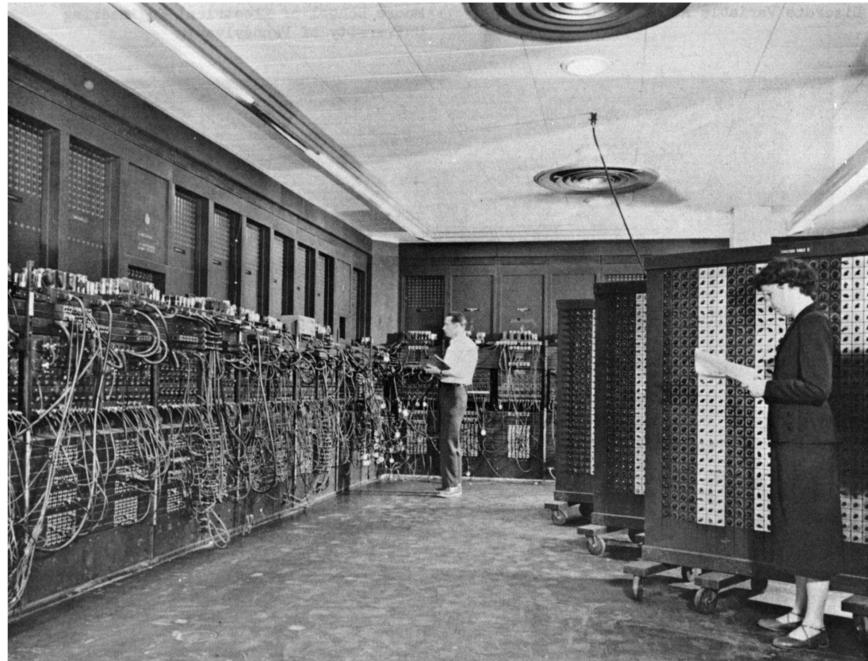


Stelo.xyz, Pttm, or Thomas Nguyen
(https://commons.wikimedia.org/wiki/File:Intel_C4004.jpg),
<https://creativecommons.org/licenses/by-sa/4.0/legalcode>



the Science Museum
(https://commons.wikimedia.org/wiki/File:Intel_4004_open.jpg),
<https://creativecommons.org/licenses/by/4.0/legalcode>

The Integrated circuit revolution



Unknown author
(https://commons.wikimedia.org/wiki/File:Glen_Beck_and_Betty_Snyder_program_the_ENIAC_in_building_328_at_the_Ballistic_Research_Laboratory.jpg), „Glen Beck and Betty Snyder program the ENIAC in building 328 at the Ballistic Research Laboratory“, marked as public domain, more details on Wikimedia Commons:
<https://commons.wikimedia.org/wiki/Terms:PD-US>



Michael Hicks from Saint Paul, MN, USA
([https://commons.wikimedia.org/wiki/File:ENIAC_on_a_Chip,_University_of_Pennsylvania_\(1995\)_-_Computer_History_Museum.jpg](https://commons.wikimedia.org/wiki/File:ENIAC_on_a_Chip,_University_of_Pennsylvania_(1995)_-_Computer_History_Museum.jpg)), „ENIAC on a Chip, University of Pennsylvania (1995) - Computer History Museum“, Cropped. by L.P., <https://creativecommons.org/licenses/by/2.0/legalcode>

FinFET and 3D transistors

- **Introduced for sub-20nm technologies**
 - FinFET (2010s)
 - Gate-All-Around Transistors (2020s)

Timeline summary

1947 --> **Point-Contact Transistor**: First working transistor

1948 --> **BJT**: Improved, smaller, producible

1959 --> **MOSFET**: Modern IC technology

2010s -> **FinFET**: Sub-20nm technology

2020s -> **Gate-All-Around Transistors**

The MOSFET transistor

Generalities

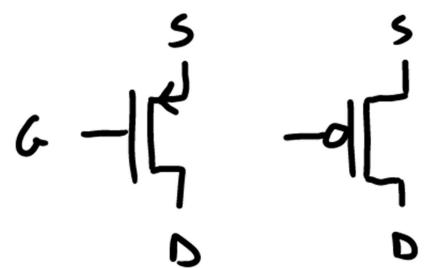
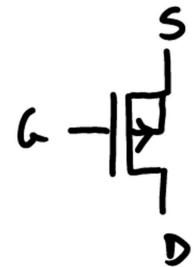
- **Metal-Oxide-Semiconductor Field-Effect Transistor (MOSFET)**
 - Most widely used transistor type today
- **Advantages**
 - High input impedance
 - Low power consumption
 - Scalability for ICs

Generalities

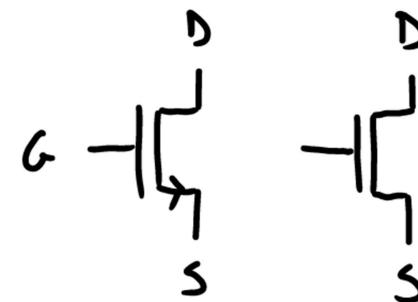
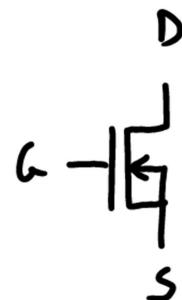
- **Two Types**
 - NMOS: Uses electrons as charge carriers
 - PMOS: Uses holes as charge carriers
- **Pins**
 - **Gate**: Controls current flow between Source and Drain
 - **Source**: Starting point of current flow
 - **Drain**: Endpoint of current flow
 - **Substrate (Body)**: The semiconductor base material (**omitted**)

Symbols

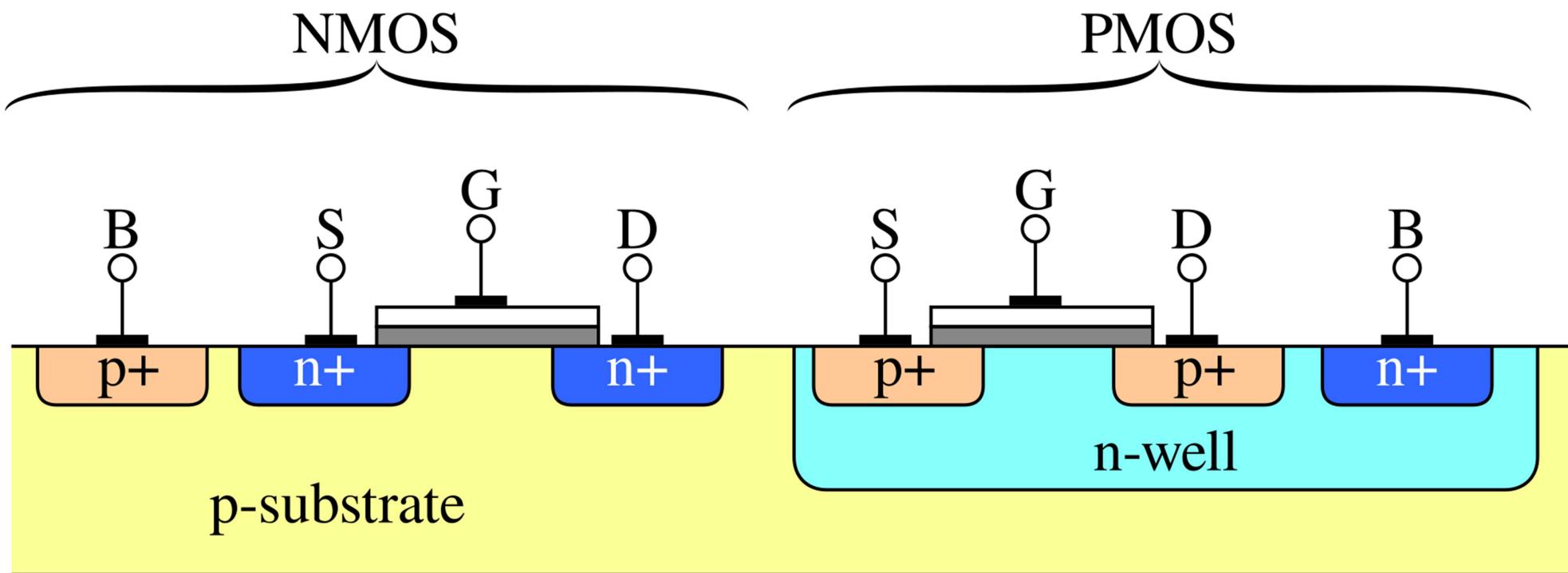
P-MDS



N-MDS



MOSFET Structure



Д.Ильин: vectorization (https://commons.wikimedia.org/wiki/File:Cmos_impurity_profile-en.svg), „Cmos impurity profile-en“, <https://creativecommons.org/publicdomain/zero/1.0/legalcode>

Working basic principle

- **Voltage at the Gate**
 - Controls a channel between Source and Drain
- **Key Mechanism**
 - Gate voltage creates an electric field, inducing a conductive channel

Working basic principle

Blackboard

MOSFET regions of operation

1. Cutoff

- $V_{GS} < V_{th}$: No current flows

2. Linear (Ohmic)

- $V_{GS} > V_{th}, V_{DS} < V_{GS} - V_{th}$: Current flows proportionally to V_{DS}

3. Saturation

- $V_{GS} > V_{th}, V_{DS} > V_{GS} - V_{th}$: Current is constant

Note : V_{th} is the Gate threshold voltage needed for conduction

MOSFET regions of operation

1. Cutoff

$$I_D = 0$$

2. Linear (Ohmic)

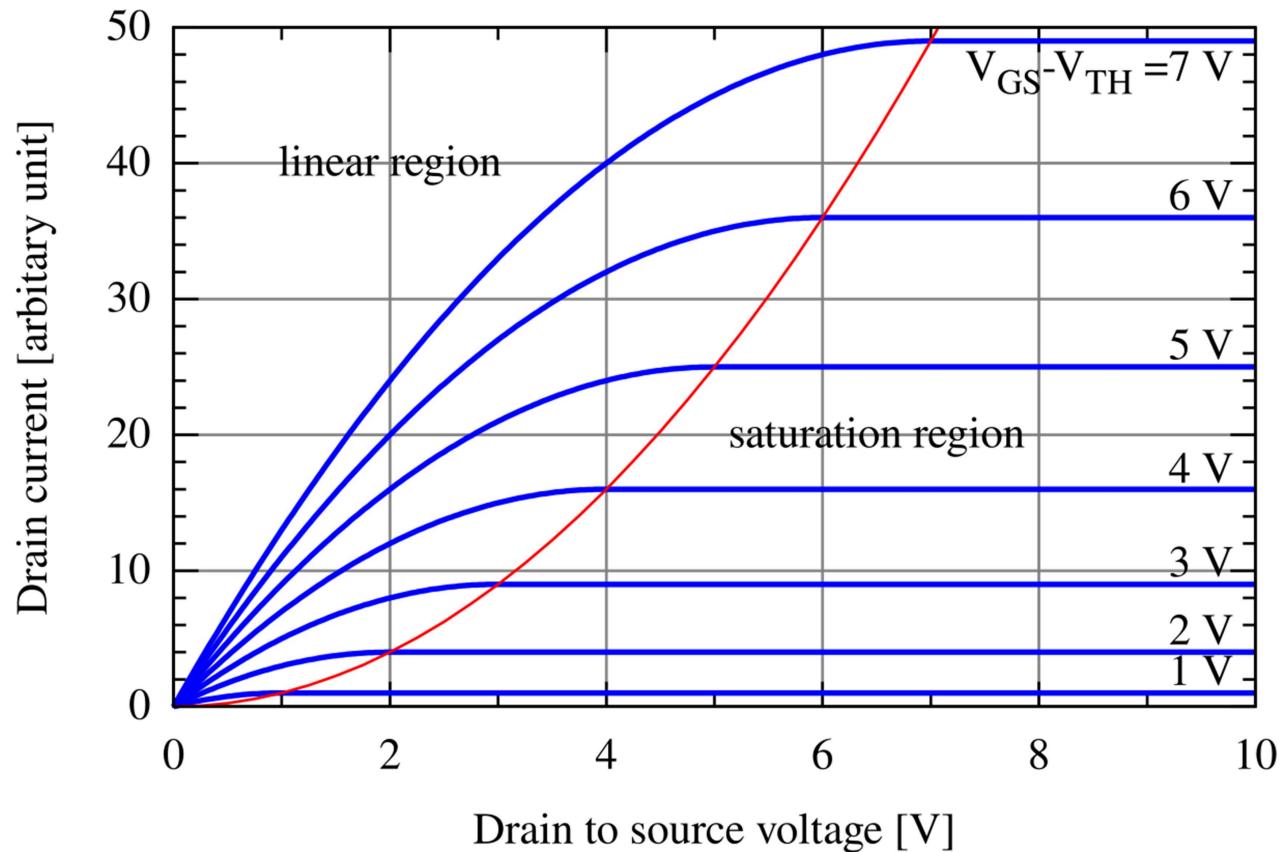
$$I_D = k \cdot (V_{GS} - V_{th}) \cdot V_{DS}$$

3. Saturation

$$I_D = \frac{k}{2} \cdot (V_{GS} - V_{th})^2$$

where $k = \frac{\mu_n C_{ox} W}{L}$ (*Process and geometry-dependent constant*)

MOSFET transfer characteristic



User:CyrilB (https://commons.wikimedia.org/wiki/File:IvsV_mosfet.svg), „IvsV mosfet“, <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Capacitance in MOSFETs

- **Reason**
 - Proximity of components where there is a potential difference
- **Effect**
 - Limits switching speed

Capacitance in MOSFETs

Blackboard

Leakage in MOSFETs

- **Subthreshold leakage**
 - Current flows even when $V_{GS} < V_{th}$
- **Gate leakage**
 - Caused by tunneling through the thin oxide layer
- **Other leakages**
 - Anywhere there is a potential difference

Leakage in MOSFETs

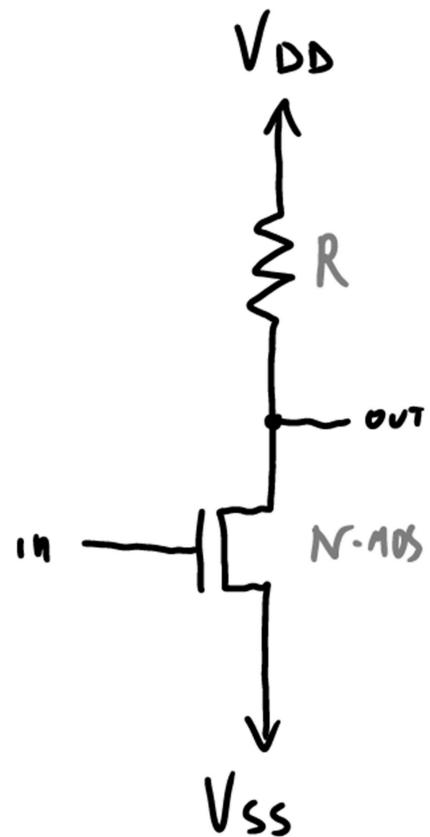
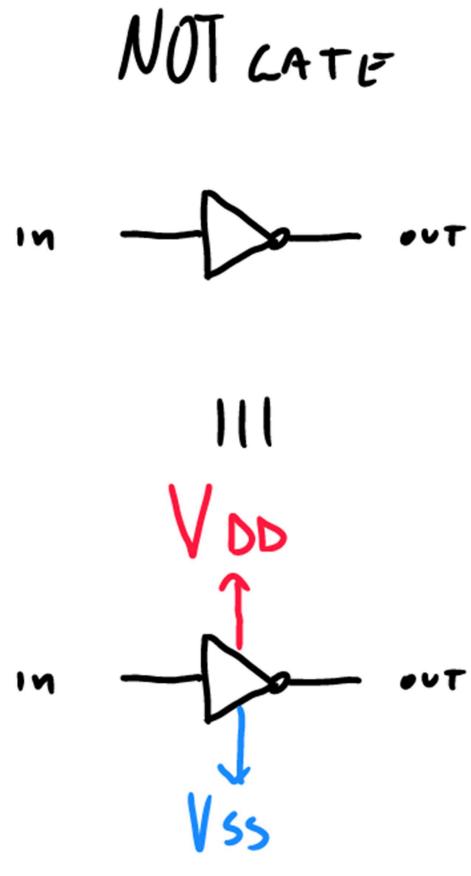
Blackboard

The inverter ('NOT' gate)

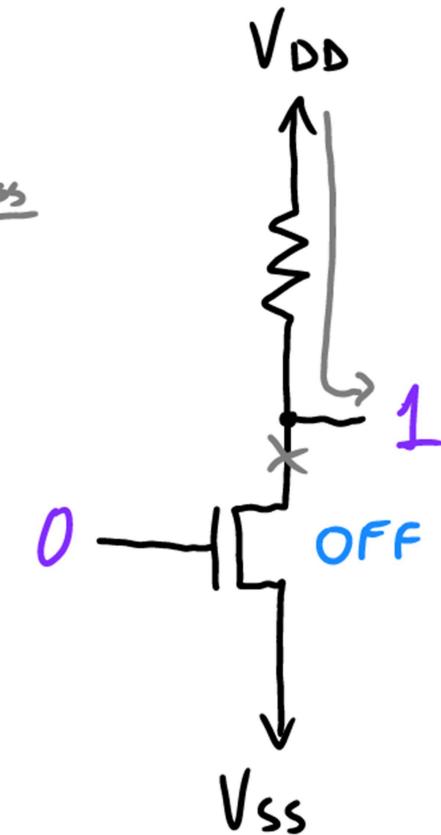
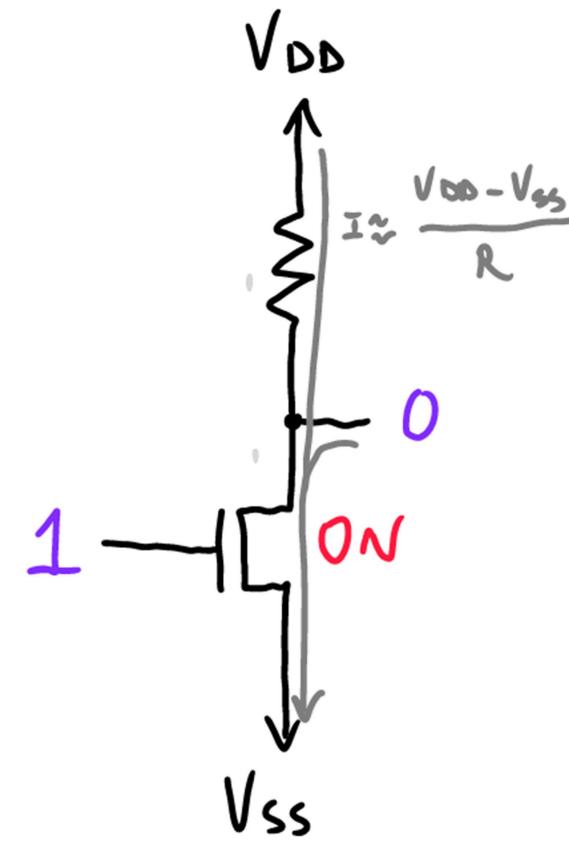
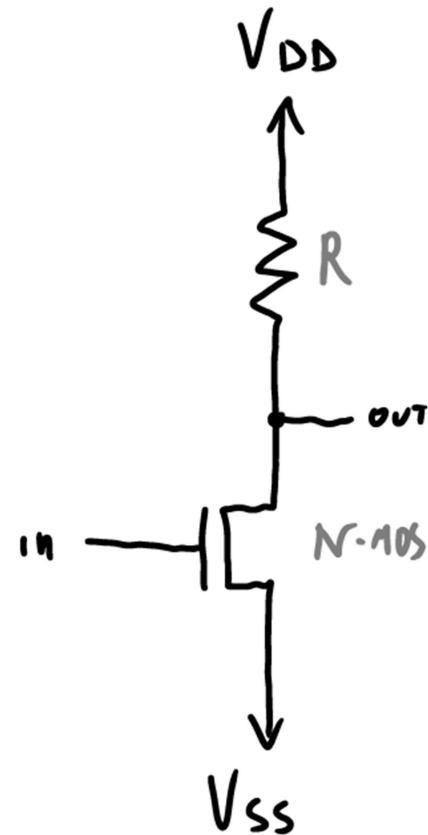
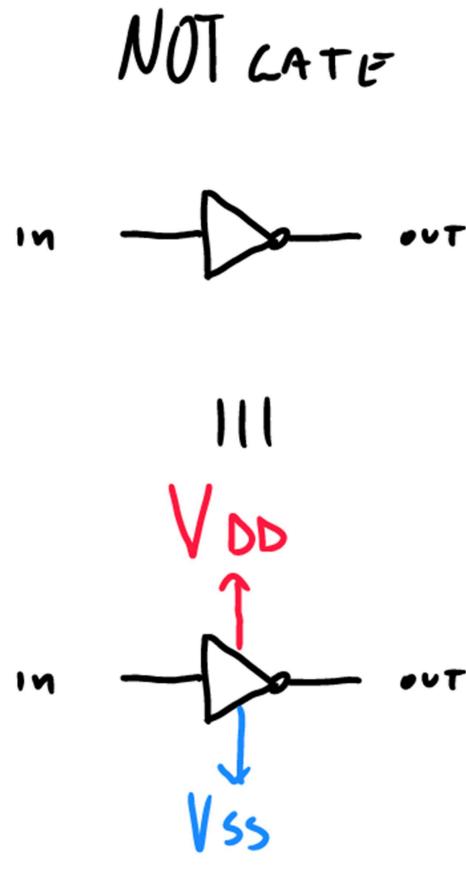
The NMOS inverter

- Single NMOS transistor with a pull-up resistor
- **Operation**
 - Input LOW: Output HIGH (resistor pulls up)
 - Input HIGH: Output LOW (NMOS conducts)

The NMOS inverter



The NMOS inverter



The NMOS inverter

- **High power consumption in the 'output LOW' state**
 - Current flows through the resistor
- **Slower operation due to resistive pull-up**

The CMOS inverter

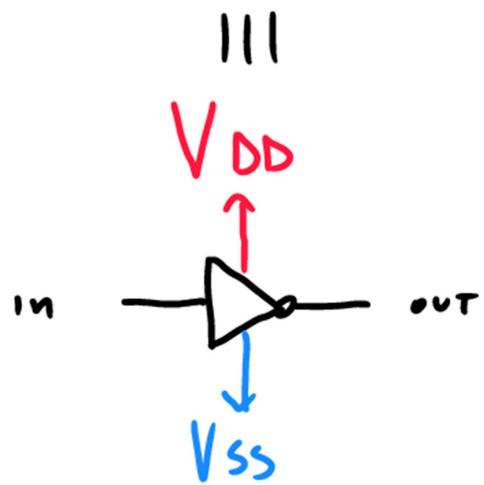
- **Complementary MOS (CMOS)**
 - Combines NMOS and PMOS transistors
- **Operation**
 - Input LOW: PMOS ON, NMOS OFF → Output HIGH
 - Input HIGH: NMOS ON, PMOS OFF → Output LOW

The CMOS inverter

NOT GATE



|||



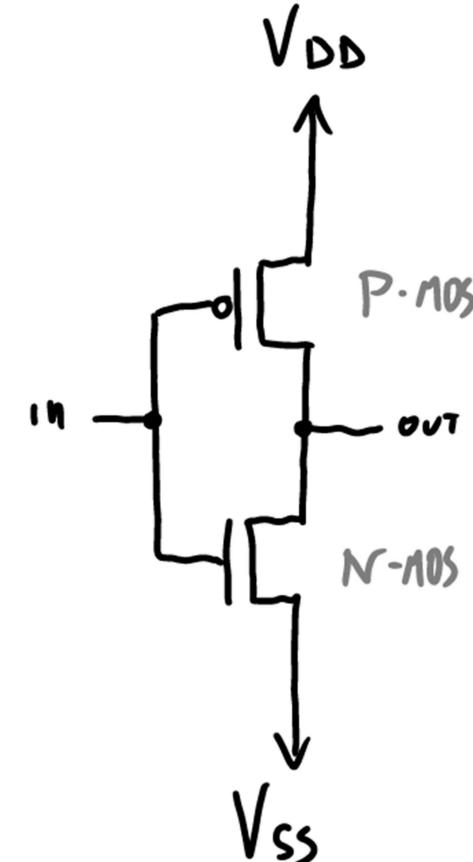
V_{DD}

P-MOS

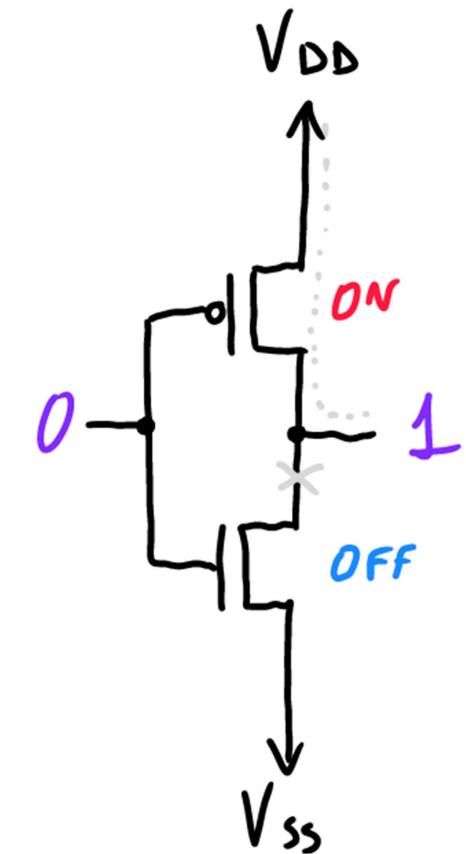
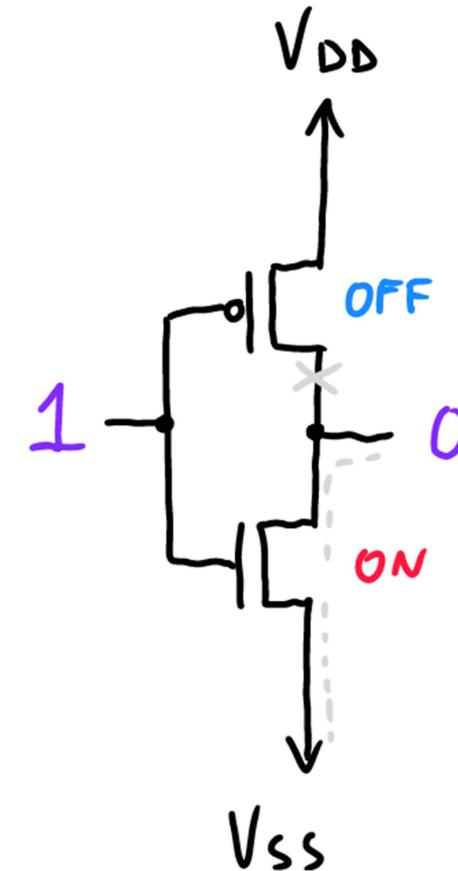
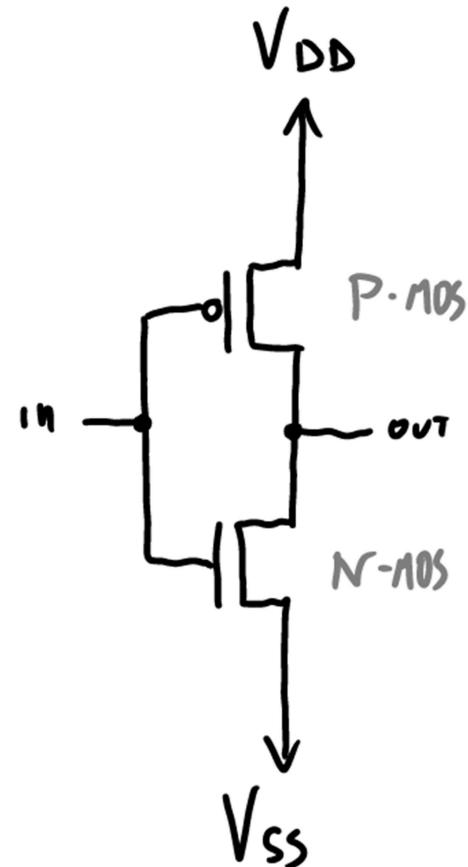
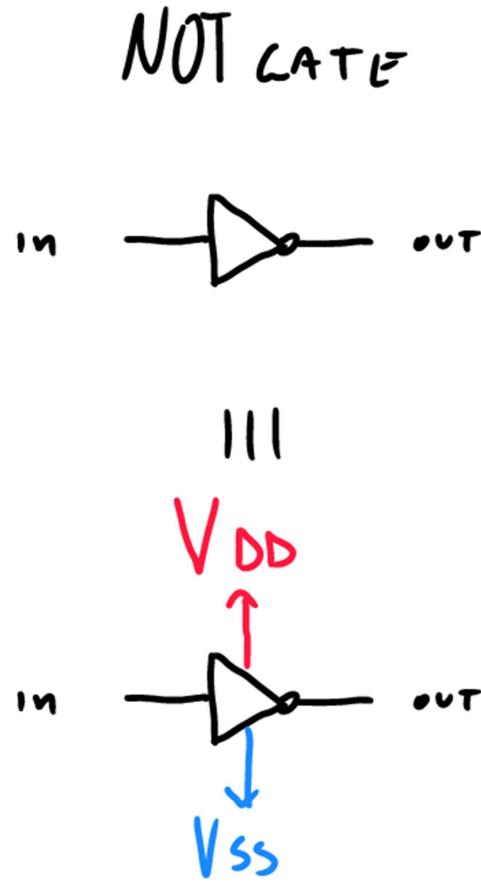
OUT

N-MOS

V_{SS}



The CMOS inverter



The CMOS inverter

- **No static power dissipation**
 - Only consumes power during switching
- **Fast switching**
 - Limited by gate capacitances

The CMOS inverter transfer characteristic

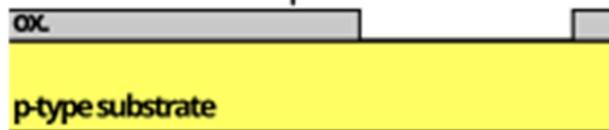
Blackboard

Fabricating a CMOS inverter in silicon

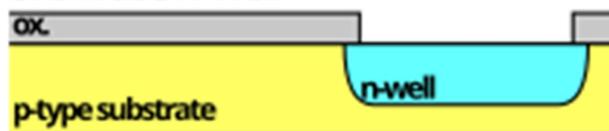
1. Grow field oxide



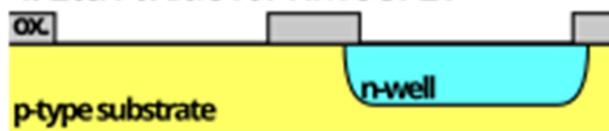
2. Etch oxide for pMOSFET



3. Diffuse n-well

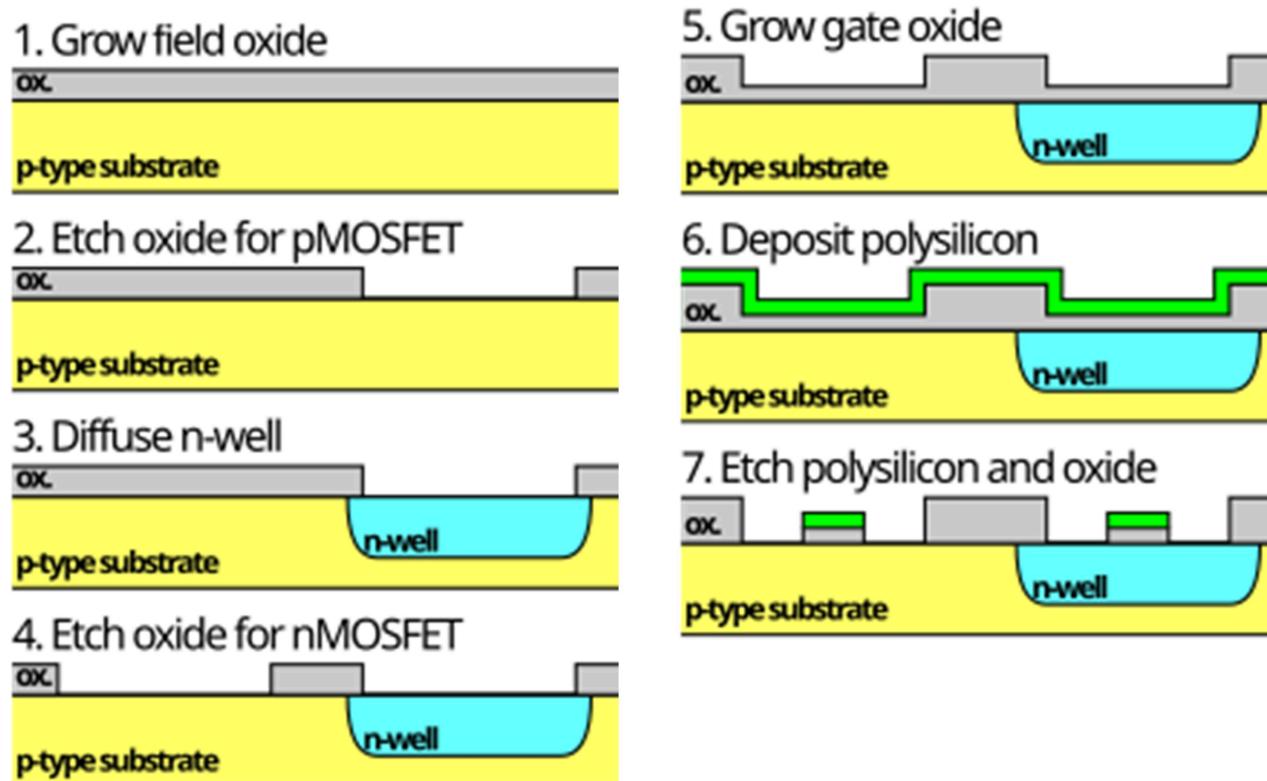


4. Etch oxide for nMOSFET



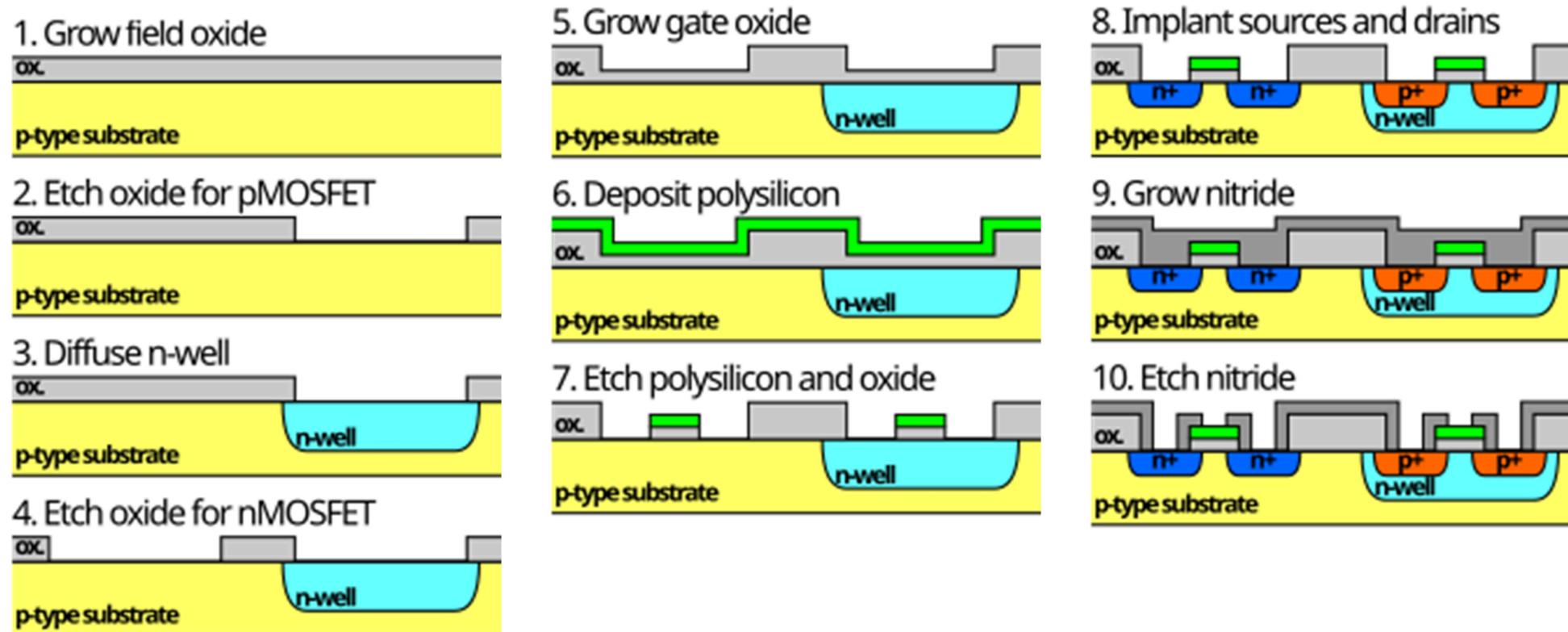
anonymous (https://commons.wikimedia.org/wiki/File:CMOS_fabrication_process.svg), „CMOS fabrication process“, Cropped. by L.P., <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Fabricating a CMOS inverter in silicon



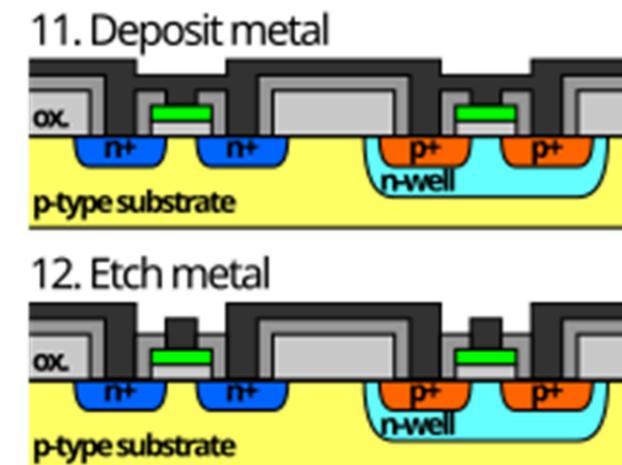
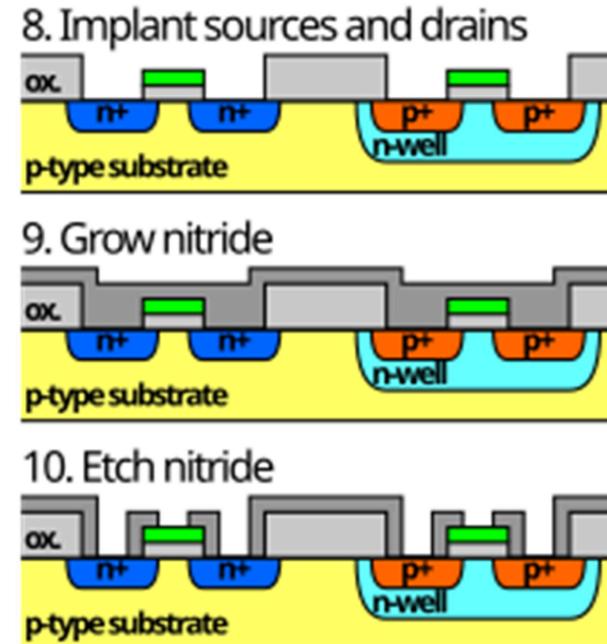
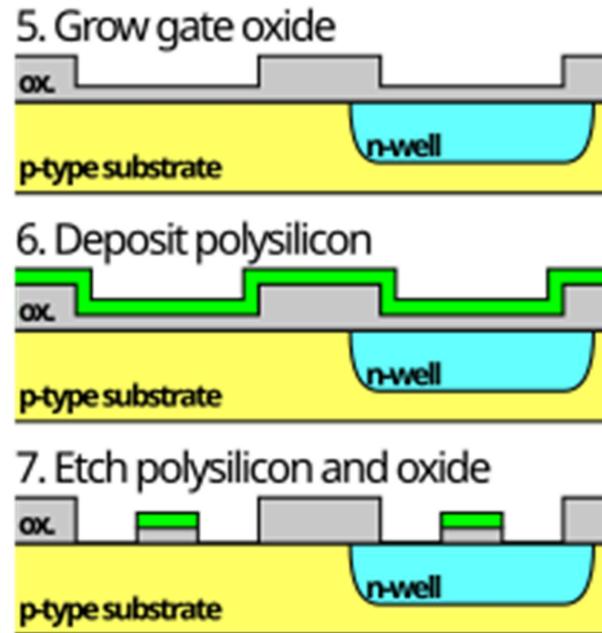
anonymous (https://commons.wikimedia.org/wiki/File:CMOS_fabrication_process.svg), „CMOS fabrication process“, Cropped. by L.P., <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Fabricating a CMOS inverter in silicon



anonymous (https://commons.wikimedia.org/wiki/File:CMOS_fabrication_process.svg), „CMOS fabrication process“, Cropped. by L.P., <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Fabricating a CMOS inverter in silicon



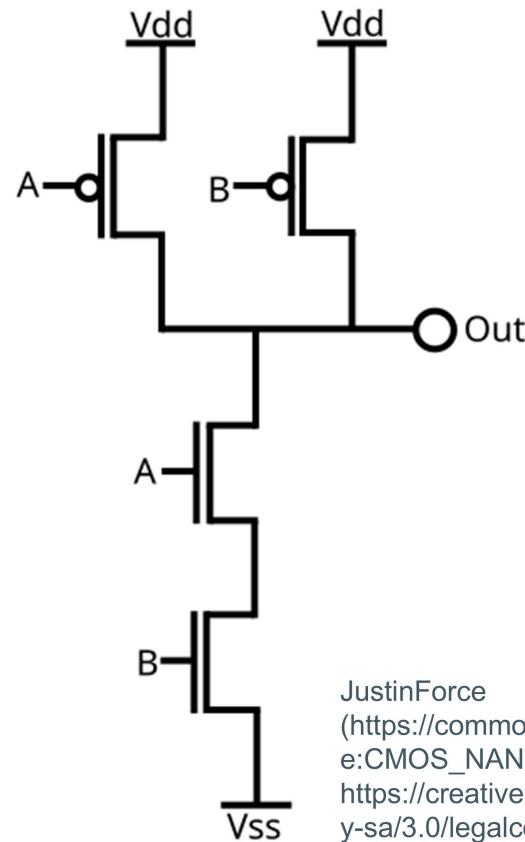
anonymous (https://commons.wikimedia.org/wiki/File:CMOS_fabrication_process.svg), „CMOS fabrication process“, Cropped. by L.P., <https://creativecommons.org/licenses/by-sa/3.0/legalcode>

Other gates

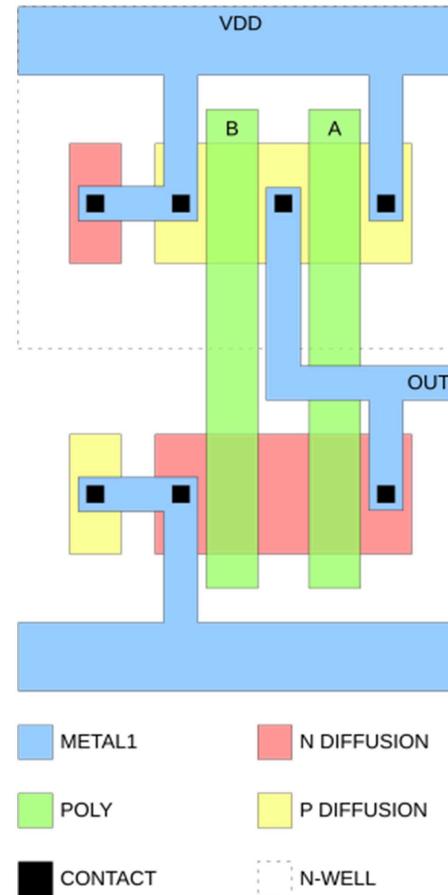
Building logic gates with CMOS

- **NAND Gate**
 - Series NMOS and parallel PMOS transistors
- **NOR Gate**
 - Parallel NMOS and series PMOS transistors

Building logic gates with CMOS (NAND)



JustinForce
(https://commons.wikimedia.org/wiki/File:CMOS_NAND.svg), „CMOS NAND“,
<https://creativecommons.org/licenses/by-sa/3.0/legalcode>



Jamesm76 at English Wikipedia
(https://commons.wikimedia.org/wiki/File:CMOS_NAND_Layout.svg), „CMOS NAND Layout“, marked as public domain, more details on Wikimedia Commons:
<https://commons.wikimedia.org/wiki/Template:PD-user>

Standard cells and custom circuits

- **Standard Cells**

- Predefined layouts for basic gates (NAND, NOR, etc.)
- Simplify chip design

- **Custom Circuits**

- Tailored for specific applications

End - Lecture 2

Laboratory

- All exercises form [SiliWiz](#)
- See Laboratory 2 file
- Feel free to skip some if you are confident with the topic